

<b>Notice of References Cited</b>	Application/Control No. 10/811,066		Applicant(s)/Patent Under Reexamination LABRUNO ET AL.	
	Examiner Maria Veronica D. Ewald		Art Unit 1722	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,418,446	12-1983	Sandberg et al.	425/574
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	K	US-			
	L	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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